

Publication statement

Title Optically controlled magnetic-field etching on the nano-scale

Authors Takashi Yatsui, Toshiki Tsuboi, Maiku Yamaguchi, Katsuyuki Nobusada, Satoshi Tojo, Fabrice Stehlin, Olivier Soppera and Daniel Bloch

The above article has been published online on 25 March 2016.

You can access it via the following link:

<http://www.nature.com/lsa/journal/v5/n3/full/lsa201654a.html>